

	Application No.	Applicant(s)	
Notice of Allowability	10/786,888	ANDO ET AL.	
	Examiner	Art Unit	
	Ngan Ngo	2814	
The MAILING DATE of this communication apperature All claims being allowable, PROSECUTION ON THE MERITS IS therewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT ROT the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED i ) or other appropriate comm IGHTS. This application is	n this application. If not included unication will be mailed in due c	d ourse. <b>THIS</b>
This communication is responsive to		•	
2. 🛮 The allowed claim(s) is/are <u>1-12</u> .			
3.   The drawings filed on are accepted by the Examine	er.		
<ul> <li>4.  Acknowledgment is made of a claim for foreign priority una)  All b)  Some* c)  None of the: <ol> <li>Certified copies of the priority documents have</li> <li>Certified copies of the priority documents have</li> <li>Copies of the certified copies of the priority documents have</li> <li>Topies of the certified copies of the priority documents have</li> </ol> </li> <li>Copies of the certified copies of the priority documents have</li> <li>Copies of the certified copies of the priority documents have</li> <li>Copies of the certified copies of the priority documents have</li> <li>Copies of the certified copies of the priority documents have</li> <li>Certified copies not received:</li> </ul>	e been received. e been received in Applicati	on No	on from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		e a reply complying with the requ	ıirements
<ol> <li>A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which giv</li> </ol>			TICE OF
<ol> <li>CORRECTED DRAWINGS ( as "replacement sheets") mure</li> <li>(a) ☐ including changes required by the Notice of Draftspers</li> <li>1) ☐ hereto or 2) ☐ to Paper No./Mail Date</li> <li>(b) ☒ including changes required by the attached Examiner Paper No./Mail Date 0704.</li> <li>Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in a percent sheet of the sheet of the</li></ol>	son's Patent Drawing Revie  's Amendment / Comment of  1.84(c)) should be written on the header according to 37 Cost of BIOLOGICAL MAT	or in the Office action of the drawings in the front (not the l FR 1.121(d). ERIAL must be submitted. N	
attached Examiner's comment regarding REQUIREMENT			
<ul> <li>Attachment(s)</li> <li>1. ☑ Notice of References Cited (PTO-892)</li> <li>2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)</li> <li>3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/Paper No./Mail Date 0204</li> </ul>	6. ☐ Interview S Paper No	nformal Patent Application (PTO Summary (PTO-413), ./Mail Date s Amendment/Comment	-152)
Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. ⊠ Examiner's 9. ⊠ Other <i>Figu</i>	s Statement of Reasons for Allov re 1.  Ngan Van Ngo Primary Examiner	vance

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## **Examiner's Amendment**

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

In the drawings:

Figure 1(b) is labeled "PRIOR ART". See MPEP 608.02(g).

Any inquiry concerning this communication should be directed to Examiner Ngan Ngo at telephone number (571) 272-1711. The fax number for the Art unit is (703) 308-7722.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the Group receptionist whose telephone number is (703) 308-0956.

Ngan Van Ngo Primary Examiner

Ngan Ngo

7/22/04

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## Reasons for Allowance

The following is an examiner's statement of reasons for allowance:

The prior arts of record do not disclose the thin film transistor comprising a semiconductor film composed of an aggregate of organic semiconductor molecules in which the organic semiconductor molecules of the semiconductor film formed in a gate electrode-projected region on a surface of the insulation film have a higher orientation order than that of the semiconductor film formed outside the region.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Ngan Van Ngo Primary Examiner

Wm J W